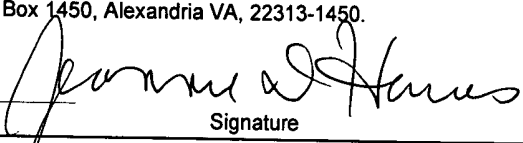


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| CERTIFICATE OF EXPRESS MAIL | |
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| DATE OF DEPOSIT | 6/9/03 |
| I hereby certify that this paper or fee is being deposited with the United States Postal Service "EXPRESS MAIL POST OFFICE TO ADDRESSEE" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria VA, 22313-1450. | |
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
David Becker et al.

Serial No.: 09/923,058

Filed: August 6, 2001

For: METHODS FOR ENHANCING SILICON
DIOXIDE TO SILICON NITRIDE
SELECTIVITY (AS PREVIOUSLY
AMENDED)

Group Art Unit: 1763

Examiner: George A. Goudreau

Atty. Dkt. No.: MCRO284—2/LWT

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7/14/03
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**RESPONSE TO OFFICE ACTION DATED MAY 7, 2003 AND
TERMINAL DISCLAIMER**

Commissioner for Patents
P.O. Box 1450
Alexandria VA, 22313-1450

This paper responds to the office action dated May 7, 2003. As this response is filed within the three-month period for response, it is believe that no extension of time fees are due. However, this response also includes a Terminal Disclaimer, for which a fee of \$110.00 is believed due pursuant to 37 C.F.R. 1.20(d) and 1.321(b)(4). This Office is authorized to deduct this terminal disclaimer fee, and any other necessary fees, from Deposit Account No. 01-2508/MCRO284-2.

Reconsideration of the application is respectfully requested.